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Sheet 1 of 1		INFORMATION DISCLOSURE STATEMENT					
FORM PTO 1449 (modified)			ATTY DOCKET NO. 2005_0321A			SERIAL NO. NEW 207532768	
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			APPLICANT Yuichiro SASAKI et al.				
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			FILING DATE April 27, 2005			GROUP	
Date Submitted to PTO: April 27, 2005							
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
AKS	AJ	10-12890	1-16-98	Japan			abstract
	AK	1 054 433	11-22-00	Europe			x
	AL	2002-170782	6-14-02	Japan			abstract
	AM	02/080254	10-10-02	WO			abstract
AKS	AN	2000-114198	4-21-00	Japan			abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
AKS	AO	Bunji MIZUNO et al., "Plasma Doping into the Side-Wall of a Sub-0.5 μ m Width Trench", Extended Abstracts of the 19 th Conference on Solid State Devices and Materials, Tokyo, 1987, pp. 319-322					
	AP						
	AQ						
EXAMINER <u>Asok Kumar Saha</u>				DATE CONSIDERED <u>11/27/06</u>			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include cop. this form with next communication to applicant.